Form 1449 (Modified)

Information Disclosure
Statement By Applicant
APR 0 3 2000

(Use Several Sheets Necessary)

Atty Docket No. LAM1P133 Applicant:

O'DONNELL

Filing Date 12/27/99

Application No.: 09/472,757

Group 1765

U.S. Patent Documents

Examiner			I	Documents	1	Sub-	Filing
Initial	No.	Patent No.	Date	Patentee	Class	1	_
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2.J.WE	2	5,174,856	12/29/92	Hwang et al.	156	643	08/26/91
X.J.W.E.	3	5,198,634	03/30/93	Mattson et al.	219	121.43	05/21/90
2.7.M-E	4	5,462,892	10/31/95	Gabriel	437	189	01/11/94
L.T.WE	5	5,705,443	01/06/98	Stauf et al.	438	722	05/30/95
LJ.WE	6	5,712,207	01/27/98	Lee et al.	438	627	05/19/97
L.J. W.E.	7	5,744,395	04/28/98	Shue et al.	438	305	10/16/96
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X. J. WE	10	5,818,085	10/06/98	Hsu et al.	257	347	07/14/97
L.J. W.E	11	5,824,604	10/20/98	Bar-Gadda	438	725	01/23/96
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Initial	No.	No.	Date	Patent Office	Class	class	Yes	No
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Other Documents

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L. T.W.E.	20	Lam Research Corp., Wafer Demonstration Report for Microchip Technolog 5864/5865, 9/99	У

Examiner

Lynette J. My-Eunin

Date Considered

Examiner: Initial citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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If from 1449 (Modified)

Information Disclosure Statement By Applicant

se Several Sheets if Necessary)

Atty Docket No.

LAM1P133/P0582

Applicant:

O'DONNELL

Filing Date

Application No.: **09/472,757**

Filing Date **12/27/99**

Group 1765

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LJ.N.E.	K	WO 97/ 11482	27-03-97	PCT	H01L	A2	Yes	
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2.594	P	PCT International Search Report, US/ISA, International Application No. PCT/US 00/35165, Washington, D.C., May 14, 2001
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Examiner	-4	Date Considered

Examiner: Initial citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.